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Box Patent Application Assistant Commissioner for Patents Washington, D.C. 20231

New U.S. Patent Application

Title: PLASMA PROCESSING APPARATUS WITH REDUCED PARASITIC CAPACITY AND LOSS IN RF POWER

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We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

- 1. Application 22 pages, including 5 independent claims and 28 claims total.
- 2. Drawings 9 sheets of formal drawings containing 12 figures.
- 3. Certified copy of Japanese Patent Application No. 2000-195165 Application No., filed June 28, 2000.

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L. P.

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- Information Disclosure Statement and Information Disclosure Citation, 4. PTO 1449 with document attached.
- 5. The filing fee is calculated as follows:

Basic Application Filing Fee					\$710	\$	710.00
	Number of Claims		Basic	Extra Claims			
Total Claims	28	-	20	8	x \$18		144.00
Independent Claims	5	-	3	2	x \$80		160.00
[] Presentation of Multiple Dep. Claim(s) +\$270							
Subtotal						\$	1014.00
Reduction by 1/2 if small entity						-	
TOTAL APPLICATION FILING FEE						\$	1014.00

A check for \$1014.00 is enclosed. The fee includes 6.

> \$710 filing fee; and \$304 additional claims fee

This application is being filed under the provisions of 37 C.F.R. § 1.53(f). Applicants await notification from the Patent and Trademark Office of the time set for filing the Declaration.

Applicants claim the right to priority based on Japanese Patent Application No. 2000-195165 Application No., filed June 28, 2000.

Please address all correspondence with respect to this application to:

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Please accord this application a serial number and filing date.

FINNEGAN. HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

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The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Rv.

Richard V. Burgujian Reg. No. 31,744

RVB/FPD/dvz Enclosures